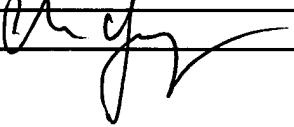


ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD FOR DRY ETCHING PHOTOMASK MATERIAL						
Application Number :	10/604,181						
Confirmation Number:							
First Named Applicant:	Timothy J. Dalton						
Attorney Docket Number:	BUR920030030US1						
Art Unit:	1756						
Examiner:	Young						
Search string:	(6544894 or 6544894 .pn						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
Cyg	1	6544894	2003-04- 08	Kobayashi	4	438	706
Cyg	2	5185058	1993-02- 09	Cathey, Jr.	—	—	—
Cyg	3	5010378	1991-04- 23	Douglas	—	—	—
Cyg	4	4916511	1990-04- 10	Douglas	—	—	—
Cyg	5	4690729	1987-09- 01	Douglas	—	—	—
	6	4659429	1987-04- 21	Fuller et al	—	—	—
Cyg	7	5837615	1998-11- 17	Rostoker	4	438	711
Signature							
Examiner Name				Date			
				1/2005			

**LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S
INFORMATION DISCLOSURE STATEMENT**

(Use several sheets if necessary)

Page 1 of 1

Attorney Docket No.:
B1|R920030030US1

Serial No.:
10/604,181

Applicants:
Timothy J. DALTON, *et al.*

Filing Date:
June 30, 2003

SEP 30 2003

Group:
1756

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

DATE CONSIDERED

1/2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.